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September 12, 2003

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03970 U.S. PTO
10/660490
09/12/03

Box: PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: OHG 135

Re: New Patent Application of: Noriko TOMITA & Takashi OHSAKO

Title: SEMICONDUCTOR SUBSTRATE SURFACE PROTECTION METHOD

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (15 Pages)
- [x] 2 Sheets of Formal Drawings (Fig. 1 through Fig. 4)
- [x] Inventor's Declaration and Power of Attorney (3 Pages)
- [x] Assignment document with cover page (3 Pages)
- [x] Claim for priority and the Priority document
- [x] Information Disclosure Statement, PTO-1449 with 2 references
- [x] Credit Card Form PTO-2038
- [x] Fee (see formula below)

Basic Fee \$750/375

\$ 750.00

Additional Fees:

Total number of claims: 18

in excess of 20: 0 times \$18/9

\$ 0.00

Number of independent claims: 3

in excess of 3: 0 times \$84/42

\$ 0.00

Multiple Dependent Claims \$280/140

\$ 0.00

Recording Fee \$40.

\$ 40.00

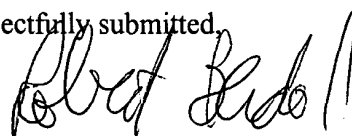
TOTAL FEES FOR THE ABOVE APPLICATION

\$ 790.00

In the event there is attached hereto no form PTO-2038, check, or a check for an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-298452, filed October 11, 2002.

Respectfully submitted,



September 12, 2003

Date

RHB:crh

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